



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIBDATASHEET

CONFIRMATION NO. 5473

Bib Data Sheet

SERIAL NUMBER 10/773,060	FILING DATE 02/04/2004 RULE	CLASS 427	GROUP ART UNIT 1762	ATTORNEY DOCKET NO. AMAT/7034.P1/DSM/LOW K/JW
-----------------------------	---------------------------------------	--------------	------------------------	--

APPLICANTS

Kang Sub Yim, Santa Clara, CA;

Yi Zheng, San Jose, CA;

Srinivas D. Nemani, Sunnyvale, CA; Li-Qun Xia, Santa Clara, CA;

Eric P. Hollar, Cupertino, CA;

** CONTINUING DATA **

This application is a CIP of 10/302,393 11/22/2002
 which claims benefit of 60/378,799 05/08/2002

** FOREIGN APPLICATIONS **

None

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 05/05/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 6	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	Verified and Acknowledged Examiner's Signature	Initials		

ADDRESS

44257

MOSER, PATTERSON & SHERIDAN, LLP/

APPLIED MATERIALS, INC.

3040 POST OAK BOULEVARD, SUITE 1500

HOUSTON, TX

77056

TITLE

Ultra low dielectric materials based on hybrid system of linear silicon precursor and organic porogen by plasma-enhanced chemical vapor deposition (PECVD)

FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-----------------------------------	---	---